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IPW

Docket No.: 071971-0390

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 53080  
Kunimasa TAKAHASHI, et al. : Confirmation Number: 6282  
Application No.: 10/553,845 : Group Art Unit: 2813  
Filed: October 20, 2005 : Examiner: Kayra Nart NEBZ  
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR PRODUCING  
THE SAME

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

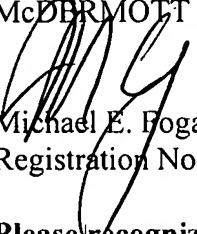
This Information Disclosure Statement is being submitted to correct typographical errors in the Form 1449 originally Submitted on October 20, 2005. The Japanese reference originally listed as JP 2002-012482 should read **JP 2000-012482**. Please note that a copy of the correct reference, JP 2000-012482 was submitted with the original information disclosure statement filed on October 20, 2005. A corrected PTO-Form 1449 is being filed herewith.

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



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